



1110-98029 PATENT

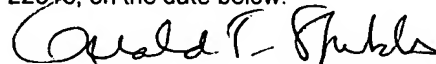
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/589,587
Applicant : INAGAKI et al.
Filed : 16 August 2006
Art Unit : 1792
Examiner : KUNEMUND, Robert M.
Docket No. : 1110-98029
Customer No. : 24628
Title : METHOD FOR
MANUFACTURING
SINGLE CRYSTAL
SEMICONDUCTOR

Confirmation No.: 2705

**CERTIFICATE OF MAILING BY
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17 June 2008
(Date)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of March 19, 2008 has been carefully reviewed and the following amendments and remarks are made in response thereto: